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\*\* CONTINUING DATA \*\*\*\*\* *NONE PD*

\*\* FOREIGN APPLICATIONS \*\*\*\*\* *NONE PD*

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Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance <i>Larry Hu</i> <i>PD</i> Examiner's Signature Initials	STATE OR COUNTRY CA	SHEETS DRAWING 2	TOTAL CLAIMS 31	INDEPENDENT CLAIMS 2
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## TITLE

Properties of a silica thin film produced by a rapid vapor deposition (RVD) process

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